

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Akira ISHIKAWA)
Japanese Priority Application No. 2002-284029) Attn: Applications
Japanese Priority Date: September 27, 2002) Branch
For: MANUFACTURING METHOD OF)
SEMICONDUCTOR DEVICE) Date: September 27, 2003

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

Reference 1, S. Kishino "Novel fundamental of semiconductor device" Ohmesha LTD, 1995, pp. 201-207 is described on page 2 of the specification, reciting the theory of hot carriers and LDD structure.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

By: 

Jeffrey L. Costellia
Registration No. 35,483

NIXON PEABODY LLP
401 9th Street, N.W.
Suite 900
Washington, D.C. 20004-2128
(202) 585-8000
NVA277955.1

